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Applicant(s): Nosowitz, N., et al

FEB 13 2004

Docket No.

IR 3700 NP

Serial No.
10/706,178Filing Date
11/12/03Examiner
not yet assignedGroup Art Unit
not yet assigned

Invention: Composition and Method for Copper Chemical Mechanical Planarization

I hereby certify that this Information Disclosure Statement & attached Info. Disclosure Citation w/ references
(Identify type of correspondence)

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PATENT

Attorney Docket No. IR 3700 NP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Group Art Unit: n/a

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For: Composition and Method for Copper Chemical Mechanical Planarization

INFORMATION DISCLOSURE STATEMENT

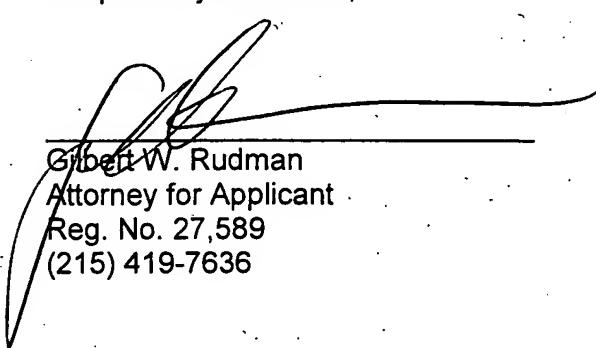
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Sir:

Applicant submits herewith a copy of the documents listed on the attached Form PTO-1449.

Respectfully submitted,

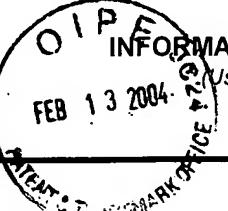
Date: 2/11/04


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Encls.

<p style="text-align: center;">INFORMATION DISCLOSURE CITATION <small>(Use several sheets if necessary)</small></p> <p style="text-align: right;">FEB 13 2004</p>				ATTY DOCKET NO. IR 3700 NP		SERIAL NO. 10/706,178	
				Nosowitz, M., et al.			
				FILING 11/12/03	GROUP n/a		
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
A1	09/091,932		Kaisaki, et al.			6/24/98	
A2	6,117,783	12/12/00	Small, et al.				
A3	4,233,112	11/11/80	Valayil, et al.				
A4	6,117,795	12/12/00	Pasch				
A5	6,068,879	5/30/00	Pasch				
A6	5,073,577	12/17/91	Anderson				
A7	5,177,908	1/12/93	Tuttle				
A8	5,234,867	8/10/93	Schultz, et al.				
A9	5,297,364	3/29/94	Tuttle				
A10	5,486,129	1/23/96	Sandhu, et al.				
A11	5,230,184	7/27/93	Bukhman				
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
B1	WO/9711484	3/27/97	PCT			✓	
B2	WO/01/44396	6/21/01	PCT			✓	
B3	WO/0112741	2/22/01	PCT			✓	
OTHER DOCUMENTS <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
		C1	Production of Sulfide Minerals by Sulfate-Reducing Bacteria During Microbiologically Influenced Corrosion of Copper, McNeil, Jones, and Little				
EXAMINER				DATE CONSIDERED			
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							

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				Nosowitz, M., et al.			
				FILING 11/12/03	GROUP n/a		
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	A12	5,245,790	9/21/93	Jerbic			
	A13	5,562,530	10/8/96	Runnels, et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
							YES
							NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
EXAMINER				DATE CONSIDERED			
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